

PATENT
8040-1052

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of: Taishi KUBOTA et al.
Appl. No.: **NEW NON-PROVISIONAL**
Filed: January 26, 2004
Title: MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE AND OXIDIZATION METHOD OF
SEMICONDUCTOR SUBSTRATE

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 26, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.